

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. .... 10/092,874  
Confirmation No. .... 9983  
Filing Date ..... March 5, 2002  
Inventor..... Y. Hishiro  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 2814  
Examiner ..... G. Peralta  
Attorney's Docket No. .... MI22-1873  
Customer No. .... 021567  
Title: Methods Of Forming Semiconductor Constructions

**RESPONSE TO JUNE 6, 2003 OFFICE ACTION**

To: Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: David G. Latwesen (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS****FAX RECEIVED****AUG 20 2003****GROUP 2800**

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